

# PRODUCT/PROCESS CHANGE NOTIFICATION

PCN IPD-PWR/12/7309 Notification Date 06/12/2012

Front-End Capacity Extension for IGBTs Automotive Ang Mo Kio (Singapore)

Table 1.	Change	Implementation	Schedule
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Forecasted implementation date for change	05-Jun-2012
Forecasted availabillity date of samples for customer	05-Jun-2012
Forecasted date for <b>STMicroelectronics</b> change Qualification Plan results availability	05-Jun-2012
Estimated date of changed product first shipment	01-Dec-2012

#### Table 2. Change Identification

Product Identification (Product Family/Commercial Product)	see taached list
Type of change	Waferfab process change
Reason for change	To be in line with ISO-TS16949
Description of the change	According to the ISO-TS16949 and in order to guarantee a double production source, this document is announcing that IGBTs Automotive grade, currently manufactured in Catania (CT6) Wafer FAB, will be also produced in 6" wafer dimension in the ST's Ang Mo Kio (Singapore) plant. IGBTs Automotive grade, produced in Ang Mo Kio (Singapore), guarantee the same quality and electrical characteristics as reported in the relevant data sheet. Devices used for qualification are available as samples
Product Line(s) and/or Part Number(s)	See attached
Description of the Qualification Plan	See attached
Change Product Identification	by the digit 6 as front-end code
Manufacturing Location(s)	

#### Table 3. List of Attachments

Customer Part numbers list	
Qualification Plan results	

	×
Customer Acknowledgement of Receipt	PCN IPD-PWR/12/7309
Please sign and return to STMicroelectronics Sales Office	Notification Date 06/12/2012
Qualification Plan Denied	Name:
Qualification Plan Approved	Title:
	Company:
🗖 Change Denied	Date:
Change Approved	Signature:
Remark	

Name	Function
Mottese, Anna	Division Marketing Manager
Aleo, Mario-Antonio	Division Product Manager
Falcone, Giuseppe	Division Q.A. Manager

## **DOCUMENT APPROVAL**

#### Dear Customer,

According to the ISO-TS16949 and in order to guarantee a double production source, please be informed that IGBTs Automotive grade, currently manufactured in Catania (CT6) Wafer FAB, will be also produced in 6" wafer dimension in the ST's Ang Mo Kio (Singapore) plant.

#### Qualification program and results availability:

The reliability test report is provided in attachment to this document.

#### Samples availability:

Samples of the test vehicle devices will be available on request starting from week 22-2011.

Product Family	Package	Part Number - Test Vehicle
IGBTs	All	STGB10NB40LZT4 STGD18N40LZ-1

#### Change implementation schedule:

The first shipments will be implemented according to our work in progress and materials availability:

Product Family	1st Shipments
IGBTs	From Week 48-2012

# Marking and traceability:

Unless otherwise stated by customer specific requirement, traceability of IGBTs Automotive grade, manufactured in 6" wafer dimension in the ST's Ang Mo Kio (Singapore) plant, will be ensured by the digit 6 as front-end code.

Sincerely Yours.



Rel 07-12

# Reliability Report on Front-End Capacity Extension for AUTOMOTIVE IGBTs Ang Mo Kio (Singapore)

General Information		Locations	
Product Lines	LZC5 IZB4	Wafer fab	Ang Mo Kio (Singapore)
Product Description	IGBT	Assembly plant	SHENZHEN (China)
Commercial Products	STGB10NB40LZT4 STGD18N40LZ-1	Reliability Lab	IMS-IPD Catania Reliability Lab
Product Group	IMS – IPD		
Product division Package Silicon Process technology	Power Transistor Division D <sup>2</sup> PAK , DPAK PT IGBT		

#### **DOCUMENT INFORMATION**

Version	Date	Pages	Prepared by	Approved by	Comment
1.0	May 2012	8	C. Cappello	G. Falcone	First issue

Note: This report is a summary of the reliability trials performed in good faith by STMicroelectronics in order to evaluate the potential reliability risks during the product life using a set of defined test methods.

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## **1 APPLICABLE AND REFERENCE DOCUMENTS**

Document reference	Short description
AEC-Q101	Stress test qualification for automotive grade discrete semiconductors

#### 2 GLOSSARY

DUT	Device Under Test
SS	Sample Size

### **<u>3 RELIABILITY EVALUATION OVERVIEW</u>**

#### 3.1 Objectives

Qualification of IGBTs Automotive grade made in 6" wafer dimension in ST's Ang Mo Kio (Singapore ).

#### 3.2 **Conclusion**

The reliability tests have shown the good performances of the devices toward the environmental tests (no failure). Moreover, the stability of electrical parameters during the accelerated tests demonstrates the ruggedness of the products and safe operation, which is consequently expected during their lifetime.



#### **4 DEVICE CHARACTERISTICS**

#### 4.1 **Device description**

IGBTs technology.

#### 4.2 Construction note

# D.U.T.: STGB10NB40LZT4 LINE: LZC5 PACKAGE: D<sup>2</sup>PAK

Wafer/Die fab. information				
Wafer fab manufacturing location	AMK6" (Singapore)			
Technology	PT IGBT			
Die finishing back side	Cr/Ni/Au			
Die size	4400 x 3570 μm <sup>2</sup>			
Metal	AlSi			
Passivation type	Nitride			

Wafer Testing (EWS) information				
Electrical testing manufacturing location	AMK6" (Singapore)			
Test program	WPIS			

Assembly information				
Assembly site	ST Shenzhen (China)			
Package description	D <sup>2</sup> PAK			
Molding compound	Epoxy Resin			
Frame material	Selected NiNiP			
Die attach process	Soft Solder			
Die attach material	Pb/Ag/Sn			
Wire bonding process	Ultrasonic			
Wires bonding materials	Al/Mg 5 mils Gate			
-	Al 10 mils Emitter			
Lead finishing/bump solder material	Pure Tin			

Final testing information				
Testing location	ST Shenzhen (China)			
Tester	IP TEST			



# D.U.T.: STGD18N40LZ-1 LINE: IZB4 PACKAGE: DPAK

Wafer/Die fab. information				
Wafer fab manufacturing location	AMK6" (Singapore)			
Technology	PT IGBT			
Die finishing back side	Cr/Ni/Au			
Die size	3990 x 2920 μm <sup>2</sup>			
Metal	AISi			
Passivation type	Teos + Nitride			

Wafer Testing (EWS) information					
Electrical testing manufacturing location	AMK6" (Singapore)				
Test program	WPIS				

Assembly information					
Assembly site	ST Shenzhen (China)				
Package description	DPAK				
Molding compound	Epoxy Resin				
Frame material	Selected NiNiP				
Die attach process	Soft Solder				
Die attach material	Pb/Ag/Sn				
Wire bonding process	Ultrasonic				
Wires bonding materials	Al/Mg 5 mils Gate				
	AI 10 mils Emitter				
Lead finishing/bump solder material	Pure Tin				

Final testing information				
Testing location	ST Shenzhen (China)			
Tester	IP TEST			



#### 5 TESTS RESULTS SUMMARY

### 5.1 Test vehicle

Lot #	Process/ Package	Product Line	Comments
1		LZC5	IGBT
2	STGB10NB40LZT4	LZC5	IGBT
3		LZC5	IGBT
1		IZB4	IGBT
2	STGD18N40LZ-1	IZB4	IGBT
3		IZB4	IGBT

### 5.2 Reliability test plan summary

#### Lot. 1÷3 - D.U.T.: STGB10NB40LZT4

LINE: LZC5

PACKAGE: D<sup>2</sup>PAK

Test	РС	Std ref.	Conditions	SS	Steps	Failure/SS	Note
		JEDD22		77 x 3	168 H	0/77	
HTRB	Ν	A-108	TA = 175℃, Vbias=330V	Lots	500 H	0/77	
		77 100		LOIS	1000 H	0/77	
		JEDD22		77 x 3	168 H	0/77	
HTGB	Ν	A-108	Tj=150℃, Vbias=12V	Lots	500 H	0/77	
					1000 H	0/77	
		JESD22		77 x 3	168 H	0/77	
HTSL	Ν	A-103	TA=175℃	Lots	500 H	0/77	
					1000 H	0/77	
PC	-	JESD22-A113-B	DRYNG 24H @ 125℃ STORE 168H @ TA=85℃ RH=85% IR Reflow @ 245℃ 3 times	251 x 3 Lots	Final	Pass	
AC	Y	JESD22 A-102	Pa=2Atm / Ta=121℃	77 x 3 Lots	96 H	0/77	
					100 cy	0/77	
тс	Y	, JESD22 A-104 TA=-55℃ TO +150℃	TA=-55℃ TO +150℃	77 x 3 Lots	200 cy	0/77	
	T				500 cy	0/77	
				1000 cy	0/77		
TF / IOL	Y	Mil-STD 750D	∆Tc=+105℃ Pd = 3.8 W	20 x 3	5K cy	0/20	
		Method 1037		Lots	10K cy	0/20	
		JESD22	TA=85℃, RH=85%	77 x 3	168 H	0/77	
H3TRB	Υ	A-101	Vbias=100V	Lots	500 H	0/77	
		77 101	V DIGG= 100 V	2013	1000 H	0/77	



#### Lot. 1÷3 - D.U.T.: STGD18N40LZ-1 LINE: IZB4

**PACKAGE: DPAK** 

Test	РС	Std ref.	Conditions	SS	Steps	Failure/SS	Note
HTRB	N	JEDD22	TA = 175℃, Vbias=290V	77 x 3	168 H 500 H	0/77 0/77	
піко	IN	A-108	TA = 175  C,  VDIAS=290  V	Lots	1000 H	0/77	
		JEDD22		77 x 3	168 H	0/77	
HTGB	Ν	A-108	Tj=150℃, Vbias=20V	Lots	500 H	0/77	
		77 100		LOIS	1000 H	0/77	
		JESD22		77 x 3	168 H	0/77	
HTSL	Ν	A-103	TA=175℃	Lots	500 H	0/77	
				_0.0	1000 H	0/77	
PC	-	JESD22-A113-B	DRYNG 24H @ 125℃ STORE 168H @ TA=85℃ RH=85% IR Reflow @ 260℃ 3 times	251 x 3 Lots	Final	Pass	
AC	Y	JESD22 A-102	Pa=2Atm / Ta=121℃	77 x 3 Lots	96 H	0/77	
					100 cy	0/77	
то	Y	JESD22	TA=-55℃ TO +150℃	77 x 3	200 cy	0/77	
тс	Ť	A-104	TA=-55℃ TO +150℃	Lots	500 cy	0/77	
					1000 cy	0/77	
TF / IOL		Mil-STD 750D	∆Tc=+105℃ Pd = 2 W	20 x 3	5K cy	0/20	
	Y	Method 1037	$\Delta 10 = 7103 \text{ C} \text{ F} \text{ U} = 2 \text{ W}$	Lots	10K cy	0/20	
		JESD22		77 x 3	168 H	0/77	
H3TRB	Y		TA=85℃, RH=85% Vbias=100V	Lots	500 H	0/77	
		A-101	v bid3=100 v	2013	1000 H	0/77	



# ANNEXES 6.0

### **6.1Tests Description**

Test name	Description	Purpose
HTRB High Temperature Reverse Bias	The device is stressed in static configuration, trying to satisfy as much as possible the following conditions:	To determine the effects of bias conditions and temperature on solid state devices over time. It simulates the devices' operating condition in an accelerated way.
HTGB High Temperature Forward (Gate) Bias	<ul> <li>low power dissipation;</li> <li>max. supply voltage compatible with diffusion process and internal circuitry limitations;</li> </ul>	To maximize the electrical field across either reverse-biased junctions or dielectric layers, in order to investigate the failure modes linked to mobile contamination, oxide ageing, layout sensitivity to surface effects.
HTSL High Temperature Storage Life	The device is stored in unbiased condition at the max. temperature allowed by the package materials, sometimes higher than the max. operative temperature.	To investigate the failure mechanisms activated by high temperature, typically wire-bonds solder joint ageing, data retention faults, metal stress- voiding.
AC Auto Clave (Pressure Pot)	The device is stored in saturated steam, at fixed and controlled conditions of pressure and temperature.	To investigate corrosion phenomena affecting die or package materials, related to chemical contamination and package hermeticity.
<b>TC</b> Temperature Cycling	The device is submitted to cycled temperature excursions, between a hot and a cold chamber in air atmosphere.	To investigate failure modes related to the thermo-mechanical stress induced by the different thermal expansion of the materials interacting in the die-package system. Typical failure modes are linked to metal displacement, dielectric cracking, molding compound delamination, wire-bonds failure, die-attach layer degradation.
<b>TF / IOL</b> Thermal Fatigue / Intermittent Operating Life	The device is submitted to cycled temperature excursions generated by power cycles (ON/OFF) at T ambient.	To investigate failure modes related to the thermo-mechanical stress induced by the different thermal expansion of the materials interacting in the die-package system. Typical failure modes are linked to metal displacement, dielectric cracking, molding compound delamination, wire-bonds failure, die-attach layer degradation.
H3TRB Temperature Humidity Bias	The device is biased in static configuration minimizing its internal power dissipation, and stored at controlled conditions of ambient temperature and relative humidity.	To evaluate the package moisture resistance with electrical field applied, both electrolytic and galvanic corrosion are put in evidence.
<b>PC</b> Preconditioning	The device is submitted to a typical temperature profile used for surface mounting devices, after a controlled moisture absorption.	To verify that the surface mounting stress does not impact on the subsequent reliability performance. The typical failure modes are "pop corn" effect and delamination.

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